

1765th

Attorney Docket No: ACT-111



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.: 09/519,165
Filed: 03/06/2000
Title: Single Mask Lithographic Process For Patterning Multiple Types Of Surface Features
Applicant(s): David W Sherrer
Gregory A. Ten Eyck
Examiner: Not yet assigned
Art Unit: 1765

TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT

THE COMMISSIONER OF PATENTS AND TRADEMARKS
Washington, DC 20231

Sir:

Transmitted herewith is an information disclosure statement pursuant to 37 CFR 1.56.

Respectfully submitted,

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Dated: Dec 8, 2000

I HEREBY CERTIFY THAT THIS CORRESPONDENCE IS BEING DEPOSITED WITH THE UNITED STATES POSTAL SERVICE AS FIRST CLASS MAIL ON THE DATE OF DEPOSIT INDICATED BELOW AND IS ADDRESSED TO: COMMISSIONER OF PATENTS AND TRADEMARKS, WASHINGTON, DC 20231.

DATE OF DEPOSIT 12/8/2000

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